

RECEIVED
CENTRAL FAX CENTER 020732-110.694
JAN 09 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:

Applicant: KORZENSKI, Michael B., et al.

Application No.: 10/807,858

Date Filed: March 24, 2004

Title: COMPOSITION USEFUL FOR
REMOVAL OF BOTTOM
ANTI-REFLECTION
COATINGS FROM
PATTERNED ION-
IMPLANTED PHOTORESIST
WAFERS

) Docket No.: 020732-110.694

) Examiner: AHMED, Shamim

) Art Unit: 1765

) Confirm. No.: 5492

) Customer No.:

24239

FACSIMILE TRANSMISSION CERTIFICATE

Attn: Examiner Shamim Ahmed

Fax No. (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop AF, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on January 9, 2007, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

19
Number of Pages (including cover)

Lillian Glenn

January 9, 2007

Date

AMENDMENT RESPONDING TO OCTOBER 24, 2006 OFFICE ACTION IN UNITED STATES PATENT APPLICATION NO. 10/807,858

Mail Stop AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This responds to the October 24, 2006 Office Action in the above-identified application.